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US DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

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2000_0964ATRANSMITTAL LETTER TO THE UNITED STATES
DESIGNATED/ELECTED OFFICE (DO/EO/US)
CONCERNING A FILING UNDER 35 U.S.C. §371U.S. APPLICATION NO.
(if known use 37 CFR 1.53) **097601484**International Application No.
PCT/EP99/00701International Filing Date
February 3, 1999Priority Date Claimed
February 5, 1998Title of Invention
METHOD AND DEVICE FOR MEASURING LUMINESCENCEApplicant(s) For DO/EO/US
Gerd MAROWSKI et al.

Applicant herewith submits to the United States Designated/Elected Office (DO/EO/US) the following items and other information:

1. ☒ This is a **FIRST** submission of items concerning a filing under 35 U.S.C. §371.
2. ☐ This is a **SECOND** or **SUBSEQUENT** submission of items concerning a filing under 35 U.S.C. §371.
3. ☒ This express request to begin national examination procedures (35 U.S.C. §371(f)) at any time rather than delay examination until the expiration of the applicable time limit set in 35 U.S.C. §371(b) and PCT Articles 22 and 39(1).
4. ☒ A proper Demand for International Preliminary Examination was made by the 19th month from the earliest claimed priority date.
5. ☒ A copy of the International Application as filed (35 U.S.C. §371(c)(2))
 - a. ☐ is transmitted herewith (required only if not transmitted by the International Bureau).
 - b. ☒ has been transmitted by the International Bureau. ATTACHMENT A
 - c. ☐ is not required, as the application was filed in the United States Receiving Office (RO/US)
6. ☒ A translation of the International Application into English (35 U.S.C. §371(c)(2)). ATTACHMENT B
7. ☐ Amendments to the claims of the International Application under PCT Article 19 (35 U.S.C. §371(c)(3)).
 - a. ☐ are transmitted herewith (required only if not transmitted by the International Bureau).
 - b. ☐ have been transmitted by the International Bureau.
 - c. ☐ have not been made; however, the time limit for making such amendments has NOT expired.
 - d. ☐ have not been made and will not be made.
8. ☒ An oath or declaration of the inventor(s) (35 U.S.C. §371(c)(4)). ATTACHMENT C
9. ☐ A translation of the annexes to the International Preliminary Examination Report under PCT Article 36 (35 U.S.C. §371(c)(5)).

Items 10. to 13. below concern other document(s) or information included:

10. ☐ An Information Disclosure Statement under 37 CFR 1.97 and 1.98.
11. ☒ An assignment document for recording. A separate cover sheet in compliance with 37 CFR 3.28 and 3.31 is included. ATTACHMENT D
12. ☐ A **FIRST** preliminary amendment.
☐ A **SECOND** or **SUBSEQUENT** preliminary amendment.
13. ☒ Other items or information:

- Notification Concerning Submission or Transmittal of Priority Document - ATTACHMENT E
- PCT Written Opinion (in German) - ATTACHMENT F
- Response to Written Opinion (in German) - ATTACHMENT G
- International Preliminary Examination Report (in German) - ATTACHMENT H
- International Search Report - ATTACHMENT I

THE COMMISSIONER IS AUTHORIZED
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ACCOUNT NO. 23-0975

U.S. APPLICATION NO. 09/601484		INTERNATIONAL APPLICATION NO. PCT/EP99/00701		ATTORNEY'S DOCKET NO. 2000 0964A	
17. [X] The following fees are submitted BASIC NATIONAL FEE (37 CFR 1.492(a)(1)-(5)): [X] Search Report has been prepared by the EPO or JPO..... \$840.00 [] Neither international preliminary examination fee (37 CFR 1.482) nor international search fee (37 CFR 1.445(a)(2)) paid to USPTO..... \$970.00 ENTER APPROPRIATE BASIC FEE AMOUNT = Surcharge of \$130.00 for furnishing the oath or declaration later than [] 20 [] 30 months from the earliest claimed priority date (37 CFR 1.492(e)).				CALCULATIONS	PTO USE ONLY
Claims	Number Filed	Number Extra	Rate		
Total Claims	10 - 20 =	-0-	X \$18.00	\$	
Independent Claims	3 - 3 =	-0-	X \$78.00	\$	
			+ \$260.00	\$	
Multiple dependent claim(s) (if applicable)					
TOTAL OF ABOVE CALCULATIONS =				\$840.00	
Reduction by 1/2 for filing by small entity, if applicable. Verified Small Entity Statement must also be filed. (Note 37 CFR 1.9, 1.27, 1.28)				\$	
SUBTOTAL =				\$840.00	
Processing fee of \$130.00 for furnishing the English translation later than [] 20 [] 30 months from the earliest claimed priority date (37 CFR 1.492(f)).				+	\$
TOTAL NATIONAL FEE =				\$840.00	
Fee for recording the enclosed assignment (37 CFR 1.21(h)). The assignment must be accompanied by an appropriate cover sheet (37 CFR 3.28, 3.31). \$40 per property +				\$ 40.00	
TOTAL FEES ENCLOSED =				\$880.00	
				Amount to be refunded	\$
				Amount to be charged	\$

a. [X] A check in the amount of \$880.00 to cover the above fees is enclosed. A duplicate copy of this form is enclosed.

b. [] Please charge my Deposit Account No. 23-0975 in the amount of \$_____ to cover the above fees.
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c. [X] The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 23-0975.

NOTE: Where an appropriate time limit under 37 CFR 1.494 or 1.495 has not been met, a petition to revive (37 CFR 1.137(a) or (b)) must be filed and granted to restore the application to pending status.

SEND ALL CORRESPONDENCE TO:

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August 3, 2000

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[2000_0964A]

Case 4-30383/P1

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Measuring method and measuring device

The invention relates to a method for exciting and determining a luminescence of an analyte which is located in contact with the surface of the waveguiding layer of a layer waveguide, in the case of which there is generated in a non-evanescent way in the volume of the analyte a luminescence which leads to the optical measuring device from the immediate proximity on the surface of the waveguiding layer luminescence radiation which has penetrated into the waveguiding layer of the layer waveguide, preferably via at least one outcoupling element for the luminescence radiation, and then measures the luminescence light, for example optoelectronically. The invention also relates to a measuring device for carrying out the method, and to a sensor platform.

In affinity sensor technology, biochemical detection elements are immobilized on the waveguide surface either directly or via an adhesion promoter layer, for the purpose of specifically detecting an analyte in a sample, which can consist of a complex mixture of substances, and for the purpose of binding the analyte molecules on the surface of the waveguide, in the region of the depth of penetration of the evanescent field. In order to detect the analyte, the sample in solution is brought into contact with the detection elements immobilized on the waveguide surface, either in stop and flow or in throughflow.

Planar waveguides have recently been developed in the field, in particular, of biochemical analysis, for the purpose of generating and detecting evanescently excited radiation. In the evanescent field, there is generated in contact with an analyte sample a luminescence, for example fluorescence, whose measurement permits a qualitative or quantitative determination of substances even in very low concentrations. The evanescently excited radiation emerging isotropically into space is determined optoelectronically by means of suitable measuring devices such as, for example, photodiodes, photomultipliers or CCD cameras. This method is disclosed, for example, in WO 95/33197. It is also possible for the fraction of the evanescently excited radiation coupled back into the waveguide to be coupled out via a diffractive optical element, for example a grating, and measured. This method is described, for example, in WO 95/33198. For the purpose of simultaneously or to follow one another [sic] carrying out multiple measurements, arrays have become known in which there are arranged on a sensor platform at least two waveguides which are driven separately with the aid of excitation light - see, for example, WO 96/35940.

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The known measuring methods place high requirements on the positioning accuracy of the excitation light with reference to the incoupling elements, in order to achieve an adequate light incoupling and thus sensitivity. The use of adjusting components is therefore mandatory, and this complicates the technical design and is evident, in particular, in the case of the construction of arrays.

In addition, one is limited to the use of essentially coherent light, in order to coordinate the positioning with the constants of the incoupling elements and such as, for example, diffractive gratings.

For classic, highly multimodal waveguides, such as, for example, multimode capillaries, multimode glass fibers or multimode glass platelets, the problem of high positioning requirements for coupling in the excitation light can be circumvented by applying the so-called "luminescence-concentration principle" as described, for example, in Sensors and Actuators B 38 to 39 (1997), pages 96 to 102 and pages 300 to 304. However, here use is made of optical waveguides which comprise the substrate itself (without an additional more highly refractive layer), which is located in an environment with a low refractive index, and in the case of which waveguides a geometrical shape permits total reflection. It is described that the luminescence light from the emission sources applied to the substrate surface, such as a polymer membrane with an embedded indicator dye, [lacuna] collected over a large solid angle and then guided in the glass substrate to a detector located on the end face of the waveguide. Such indicator dyes are typically used in high, for example millimolar, concentrations. Such thick glass substrates used as multimodal waveguides are not suitable for measuring very low detection concentrations.

It has now been found, surprisingly, that even in the case of optical layer waveguides comprising a transparent substrate and a highly refractive waveguiding layer it is possible to apply the principle of the "luminescence collector", and thus the problems associated with the coupling in of the excitation light are completely avoided when the excitation radiation is directed without the use of incoupling elements at least partially directly onto the volume of the analyte sample in order to generate the luminescence for example in a reflected-light or transmission arrangement. The luminescence radiation generated in the analyte sample in the immediate proximity of the surface of the waveguiding layer is, surprisingly, coupled into the waveguiding layer to a measurable extent and can, for example, be detected optoelectronically at the end face of optical fibers or planar waveguides or via outcoupling

[illegible]

It has been found, surprisingly, that not only luminescence excited by optical radiation, but even luminescence generated by other mechanisms such as, for example, chemiluminescence, triboluminescence, bioluminescence or electroluminescence, can be measured optoelectronically with the aid of layer waveguides, and this makes available a new method for highly sensitive determination of such luminescence radiation.

low technical outlay in the use of sensor platforms with at least two separate waveguiding regions (sensor fields) for simultaneous measurements.

virtually background-free detection by means of a detection position completely separate in space from the site of excitation,
technically simple implementation of array formats such as, for example, a microtiter plate format, with adaptation to standardized sizes,
economic, cost-effective production even of compact forms of sensor systems, since requirements are placed on optomechanical adjusting devices,
use of cost-effective, freely selectable and commercial light sources, the wavelength region being set, if appropriate, by filters,
use of excitation light with a wavelength of <450 nm, and possibility of excitation even with the aid of UV light,
use of sensor platforms with open cutouts in the nl to μ l regions for holding samples,
use of layer waveguides, and
low energy density of the excitation radiation, accompanied by gentle treatment of the analyte samples.

A first object of the invention is a method for exciting and determining a luminescence in an analyte sample which is located in contact with the waveguiding layer of an optical layer waveguide, which is defined in that the luminescence is generated by non-evanescent excitation in the volume of the analyte sample, and the luminescence radiation generated in the immediate proximity of the surface of the waveguiding layer is conducted to the measuring device and determined after penetrating said waveguiding layer.

In the immediate proximity of the surface of the waveguiding layer (denoted below as immediate optical proximity) means, for example, a distance of at most approximately one wavelength of a luminescence light, preferably of at most half a wavelength and, with particular preference, of at most approximately a quarter wavelength from the surface of the waveguiding layer.

The luminescence, for example a fluorescence, can be excited in various ways. It is possible to arrange in the region of the sample holder electrodes with the aid of which the luminescence is excited by the application of an electric field. A chemiluminescence can be generated in the analyte sample by means of combining suitable chemicals. The excitation of luminescence is preferably performed optically by the direct (without incoupling element) non-evanescent irradiation of the analyte sample with the aid of light of suitable wavelengths. The wavelength region can reach, for example, from the shortwave UV to the near IR,

It is possible to use both coherent and noncoherent radiation, and thus any desired light source, for example a polychromatic one. The radiation can be focused with the aid of lenses or mirrors and/or filters can be used to set narrower wavelength regions. It is also possible to use polarized radiation. Suitable radiation sources are, for example, lasers, diode lasers and white light from light-emitting diodes or incandescent or filament lamps such as, for example, halogen or mercury-vapor lamps.

Optical layer waveguides are known in abundance and some are commercially available. For the method according to the invention, these can have different geometrical shapes, for example optical fibers, cylindrical bodies or planar waveguides. The substrate material with a low refractive index can be selected from organic glasses (for example polycarbonate) or inorganic glasses (glasses, quartz, SiO_2) and the waveguiding layer with a higher refractive index can be selected from plastics or metal oxides such as Ta_2O_5 , TiO_2 , ZnO , HfO_2 , ZrO_2 or Nb_2O_5 . Preference is given to waveguides with very thin waveguiding layers and a high refractive index, in which only a few (for example 1 to 3) modes are conducted.

The thickness of the waveguiding layer can be approximately 50 nm to 2000 nm, preferably 80 nm to 400 nm, very particularly from 100 to 200 nm. The optimum selection of the layer thickness is a function of the wavelength of the luminescence to be detected. It is preferably 50 nm up to a wavelength, particularly preferably from 50 nm up to a half wavelength, very particularly preferably from 50 nm up to a quarter wavelength. At the same time, waveguiding layers are preferred with have as high as possible a refractive index, that is to say preferably of at least 1.8, particularly preferably of at least 2.0 and very particularly preferably of at least 2.2. As a result of these parameter values, the optical near field directly

Planar waveguides are provided with at least one outcoupling element for the luminescence radiation, for example prisms or, preferably, diffractive elements.

Planar waveguides are known and are commercially available. They can have one or more mutually opposite diffractive elements for coupling out the excited luminescence radiation. The diffractive elements are preferably of monodiffractive design for the purpose of detecting luminescence of a single emission band. If luminescences of different wavelengths are to be detected, the diffractive elements are preferably of multidiffractive design. Multidiffractive grating couplers for use in measuring arrangements for detecting changes in the so-called effective refractive index in the evanescent field of a waveguide are likewise known and described, for example, in WO 95/14225.

The individual lines of the diffractive elements can be straight or bent and also be of circular design in the case of only one existing diffractive element. If two diffractive elements are

Variable	Mean	SD	Min	Max
Age	38.5	10.5	25	55
Gender	Male	Female		
Marital status	Married	Single		
Education	High school	College		
Occupation	Manager	Worker		
Income	\$10,000	\$20,000		
Health status	Good	Poor		
Exercise frequency	Weekly	Monthly		
Stress level	Low	High		
Sleep quality	Good	Poor		
Dietary habits	Healthy	Unhealthy		
Alcohol consumption	None	Regular		
Tobacco use	Non-smoker	Smoker		
Family size	2	3		
Work hours	40	50		
Commuting time	30	45		
Home ownership	Renter	Owner		
Neighborhood safety	Safe	Unsafe		
Access to green spaces	Yes	No		
Public transportation	Used	Not used		
Crime rate	Low	High		
Weather conditions	Good	Poor		
Local economy	Strong	Weak		
Community involvement	Active	Passive		
Local government	Effective	Ineffective		
Local culture	Diverse	Homogeneous		
Local history	Rich	Poor		
Local infrastructure	Good	Poor		
Local services	Good	Poor		
Local amenities	Good	Poor		
Local environment	Good	Poor		
Local quality of life	Good	Poor		
Local satisfaction	High	Low		
Local happiness	High	Low		
Local well-being	High	Low		
Local health	Good	Poor		
Local education	Good	Poor		
Local employment	Good	Poor		
Local income	Good	Poor		
Local wealth	Good	Poor		
Local power	Good	Poor		
Local status	Good	Poor		
Local reputation	Good	Poor		
Local image	Good	Poor		
Local identity	Good	Poor		
Local pride	High	Low		
Local loyalty	High	Low		
Local commitment	High	Low		
Local participation	High	Low		
Local engagement	High	Low		
Local involvement	High	Low		
Local contribution	High	Low		
Local impact	High	Low		
Local influence	High	Low		
Local power	High	Low		
Local status	High	Low		
Local reputation	High	Low		
Local image	High	Low		
Local identity	High	Low		
Local pride	High	Low		
Local loyalty	High	Low		
Local commitment	High	Low		
Local participation	High	Low		
Local engagement	High	Low		
Local involvement	High	Low		
Local contribution	High	Low		
Local impact	High	Low		
Local influence	High	Low		
Local power	High	Low		
Local status	High	Low		
Local reputation	High	Low		
Local image	High	Low		
Local identity	High	Low		
Local pride	High	Low		
Local loyalty	High	Low		
Local commitment	High	Low		
Local participation	High	Low		
Local engagement	High	Low		
Local involvement	High	Low		
Local contribution	High	Low		
Local impact	High	Low		
Local influence	High	Low		
Local power	High	Low		
Local status	High	Low		
Local reputation	High	Low		
Local image	High	Low		
Local identity	High	Low		
Local pride	High	Low		
Local loyalty	High	Low		
Local commitment	High	Low		
Local participation	High	Low		
Local engagement	High	Low		
Local involvement	High	Low		
Local contribution	High	Low		
Local impact	High	Low		
Local influence	High	Low		
Local power	High	Low		
Local status	High	Low		
Local reputation	High	Low		
Local image	High	Low		
Local identity	High	Low		
Local pride	High	Low		
Local loyalty	High			

In the case of the use of optical glass fibers, the method can be carried out such that the analytes are put into a measuring cell, for example a cuvette, which can be designed as a closed cell or a flow cell. One or more glass fibers can be connected to a closure designed as a measuring head. The luminescence radiation guided to the end face of a glass fiber can then be measured optoelectronically. The irradiation of the analyte sample can be performed through the cuvette, if appropriate via an optical window. A part or the entire volume of an analyte sample can be irradiated. Irradiation can be performed at an oblique angle, preferably at a right angle to the glass fiber.

In the case of planar waveguides, the element provided for holding an analyte, for example a sample container in the form of a depression, is generally integrated on the waveguiding layer in contact with the waveguide. The sample containers can in this case have a volume of 0.1 nl to 100 μ l, and preferably 10 nl to 10 μ l. The sample containers can be open or closed at the top, flow cells being involved in the case of the second named embodiment. The planar waveguides with applied sample containers are denoted below as sensor platforms.

The optical coupling elements, preferably designed as diffractive gratings, can be arranged inside and outside the sample containers. This yields different requirements for the properties of the second layer which is brought into contact with the waveguiding layer and in which the sample containers are produced. If the optical coupling elements are situated inside the sample containers, there are no further special requirements for the optical

Table 1. Demographic characteristics of the study population	
Characteristic	Frequency (%)
Age (years)	
< 18	10 (10.0)
18-24	20 (20.0)
25-34	30 (30.0)
35-44	25 (25.0)
45-54	15 (15.0)
≥ 55	10 (10.0)
Gender	
Male	40 (40.0)
Female	60 (60.0)
Ethnicity	
White	30 (30.0)
Black	20 (20.0)
Hispanic	10 (10.0)
Asian	5 (5.0)
Other	5 (5.0)
Marital status	
Married	30 (30.0)
Single	20 (20.0)
Divorced	10 (10.0)
Widowed	5 (5.0)
Never married	5 (5.0)
Education level	
High school or less	10 (10.0)
Some college	20 (20.0)
Bachelor's degree	30 (30.0)
Master's degree	10 (10.0)
PhD or higher	5 (5.0)
Occupation	
Unemployed	10 (10.0)
Service worker	10 (10.0)
Healthcare worker	10 (10.0)
Professional	10 (10.0)
Managerial	10 (10.0)
Executive	5 (5.0)
Self-employed	5 (5.0)
Retired	5 (5.0)
Income (USD/year)	
< 10,000	10 (10.0)
10,000-19,999	20 (20.0)
20,000-29,999	10 (10.0)
30,000-39,999	10 (10.0)
40,000-49,999	10 (10.0)
50,000-59,999	10 (10.0)
60,000-69,999	5 (5.0)
70,000-79,999	5 (5.0)
80,000-89,999	5 (5.0)
90,000-99,999	5 (5.0)
≥ 100,000	5 (5.0)

The orientation of the grating lines in the case of diffractive gratings as coupling elements is preferably essentially in the same direction as the course of the border of the sample containers. In the case of closed, for example circular or elliptic, diffractive elements, the sample containers are preferably located at their center. In the case of two or more interrupted diffractive elements, the sample containers are preferably located in the middle between opposite diffractive elements.

The sensor platforms can be designed such that they comprise only one waveguide with diffractive elements, or they can comprise a one-dimensional or two-dimensional arrangement of at least two waveguides with diffractive elements, it being possible to arrange an arbitrary number of waveguides with diffractive elements one behind the other and/or next to one another, for example up to 100 or more, advantageously 2 to 50 per row and/or line. These arrangements can be rectangular or round, for example. Particularly if the sample containers are open at the top, the external dimensions of the sensor platforms, and the arrangement of the sample containers can advantageously correspond to the shape of known and possibly standardized microtiter platforms, the number of the sample containers

on a sensor platform preferably being an integral multiple of 96 as the traditional standard for microtiter plates.

In this connection, sample containers can be dispensed with when use is made of one-dimensional or two-dimensional arrangements of at least two waveguides with diffractive elements (arrays), and the analyte sample to be investigated can be applied directly to the measuring regions (sensor fields) of the waveguiding layer. It is possible to use known methods for this purpose, such as, for example, carrying out the application using micropipettes or inkjet printers.

The production of sensor platforms with open sample containers can be performed using methods known per se, for example photolithographically by means of photopolymerizable layers which are applied to the waveguiding layer, possibly via an adhesion-promoting interlayer, the latter having to be transparent at least in the case of the luminescence wavelength to be detected, if the diffractive elements are located outside the sample containers. Another possibility consists in applying vacuum vapor deposition methods with a mask, with the aid of which a multiplicity of materials can be applied, chiefly oxides such as, for example, SiO_2 or Al_2O_3 . A further possibility consists in applying ablation methods such as, for example, etching methods, with the aid of a mask and/or laser irradiation. The methods can also be combined.

In the case of sensor platforms with one-dimensional or two-dimensional arrangements of more than one sensor elements, which are equipped with diffractive elements for coupling out luminescence and formed in a continuous waveguiding layer, it can be expedient to interrupt the waveguidance between neighboring sensor elements by applying layers which are absorbing at least in the case of the luminescence wavelength to be detected. The application of the absorbing layers can be done, for example, by spreading or printing. Furthermore, this can be performed by vapor deposition of metal oxides, using vacuum coating methods, or with the use of light-absorbing materials such as, for example, intermediate cutouts, filled with carbon or blackened materials, in the layer, containing the sample containers, in contact with the waveguide surface. Interference owing to crosstalk of excitation and/or luminescence light is thereby suppressed.

The individual sensor elements can also be separated by an interruption of the waveguiding layer around the said sensor element, in order to avoid interference through crosstalk. The

If the diffractive elements are situated outside the sample containers, it is also possible to prefabricate cover layers composed of a [sic] materials transparent to the luminescence radiation and, if appropriate, also to the excitation radiation at least in the region of the depth of penetration of the evanescent field of guided luminescence light, preferably up to at least ten micrometers, possibly with, as described above, light-absorbing regions outside the region of the sensor fields and the associated diffractive elements, and then to connect them to the waveguiding layer, as the case may be with the aid of an adhesion promoter for which the same requirements for transparency or absorption properties are valid as a function of the position with reference to the diffractive elements.

In carrying out the method according to the invention with planar waveguides, it is possible to irradiate the analyte sample from outside, that is to say upstream of or between the outcoupling elements directly at an inclined or preferably right angle, with reference to the waveguide, (a) from above through the analyte sample in the direction of the waveguiding layer and through the waveguide or (b) preferably from below through the waveguide, from the direction of the substrate material. It can be advantageous in this case to use mirrors on the side of the sensor platform opposite the direction of irradiation to produce a two fold passage of the excitation light through the sample if an increase in scattered light falling onto the detection units is avoided by the shaping of the optical excitation geometry. In the case of sample containers of the sensor platform which are closed at the top, and of irradiation of the excitation light from the direction of the substrate material, it is possible, for example, for the top side of the cutouts to be mirror-coated. In the case of irradiation of the excitation light from above through the analyte sample, the outside of the substrate material can be mirror-coated in the region of the sample containers and between the diffractive elements.

The simultaneous irradiation of one-dimensional or two-dimensional arrays of sensor elements can be performed, for example, using a light beam expanded over a large area (for simultaneous irradiation of a two-dimensional array) or elliptically or in the shape of a slit (for simultaneous irradiation of the one-dimensional array). However, this is associated with the production of different irradiation intensities on the various sensor elements, something

Table 1. Demographic characteristics of the study population	
Age (years)	65.0 ± 10.0
Gender	
Male	50 (50.0%)
Female	50 (50.0%)
Education (years)	12.0 ± 2.0
Marital status	
Married	40 (80.0%)
Single	10 (20.0%)
Occupation	
Retired	30 (60.0%)
Unemployed	20 (40.0%)
Income (USD/month)	1,200 ± 300
Health insurance	
Yes	45 (90.0%)
No	5 (10.0%)
Comorbidities	
Hypertension	35 (70.0%)
Diabetes	20 (40.0%)
Cholesterol	25 (50.0%)
Smoking status	
Current	10 (20.0%)
Former	20 (40.0%)
Never	20 (40.0%)
Alcohol consumption	
Yes	15 (30.0%)
No	35 (70.0%)

- very high conversion efficiency of the laser current into emitted laser light and a relatively low generation of heat associated therewith, which permits a high packing density on a platform, in particular in the case of additional use of cooling elements, on which demands which are correspondingly relatively low are placed;
- very small dimensions of the emitting laser aperture in the lower micrometer region, which permits the measuring arrangement to be miniaturized to an extreme extent together with the vertical arrangement of the laser cavity on the substrate and with the possible high packing density;
- very low variation in the emission intensities of VCSELs produced on a single wafer, and the possibility of selective driving given an appropriate design of the control electronics;
- very small aperture angles of the emission cone in the case of the use of small exit openings and monomodal emission up to milliwatt intensities given the use of low drive currents; and

- low production costs per individual VCSEL owing to simultaneous production of a large number of VCSELs on a single wafer.

The fraction, generated in the near field of the waveguide, of the luminescence radiation excited in the analyte volume and coupled at least partially into the waveguide is guided in the latter and coupled out at the optical coupling elements. The coupled-out luminescence light can then be directed onto optoelectronic detection elements and measured.

Since, in addition to the dependence on the thickness of the waveguiding layer, the strength of the evanescent field of guided modes is also dependent on their polarization (transverse electric, TE, or transverse magnetic, TM), something which is also valid for the mechanism, subject to similar physical laws, of the coupling in (the penetration) of luminescence generated in the near field of the waveguide, for the purpose of increasing the sensitivity, that is to say for the purpose of achieving deeper detection limits, it can be advantageous to detect the luminescence coupled out at the diffractive elements in a polarization-selective fashion. This is facilitated by virtue of the fact that the coupling-out of luminescence light of the same wavelength but different polarization (TE or TM) is performed at clearly different angles. It can, in particular, be advantageous in the case of coupling out spectrally broadband luminescence, that is to say luminescence coupled out under a wide cone, to make use of additionally polarization-selected optical components in the beam path of the coupled-out luminescence between the diffractive outcoupling elements and the optoelectronic detection units.

Further details on the design of a measuring arrangement and on the selection of light sources, optical elements for guiding and discriminating the excitation radiation and luminescence radiation, as well as detection units for determining the luminescence radiation are described in detail in WO 95/33197 and WO 95/33198.

In using measuring cells in which the sample liquid comes into contact with the diffractive coupling elements, the problem arises that the conditions for coupling in the excitation light can change through molecular adsorption or binding onto the incoupling elements. In addition, excitation of unbound luminescent or fluorescent molecules by means of the fraction of the excitation light which is not coupled partially into the waveguide but enters the solution without diffraction as zero order excites in the depth of the sample background luminescence or background fluorescence which can be coupled partially into the waveguide

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via the optical coupling elements and impair the accuracy and sensitivity of the determination of the analyte.

A flow cell made from silicone rubber and applied to an optical waveguide with incoupling and outcoupling gratings is described in Analytical Chemistry, volume 62, No. 18 (1990), pages 2012 to 2017. The incoupling and outcoupling elements are situated in the region of the sample flow channel. This arrangement is used to measure variations in the light absorption and in the refractive index, without a selective interaction with specific detection elements on the waveguide surface. Adsorption phenomena on the surface are not taken into consideration for the analyte, a dye solution in the case of the absorption-dependent measurement, or liquids of different refractive indexes in the case of measurement as a function of refractive index. In the case of these very insensitive measurements, the changes to be expected in the effective refractive index for a mode guided in the waveguide can be neglected even in the case of adsorption of a monolayer of molecules by comparison with the strong variations in the refractive index of the solutions supplied, by contrast with the interference to be expected in the case of the very much more sensitive method of determining the luminescence generated in the evanescent field. In the case of the measuring method which is a function of the refractive index and based on the change in the incoupling or outcoupling angle, the contact between the sample and the coupling elements is, of course, even a necessity for generating the measuring signal. Because of this configuration, with incoupling and outcoupling elements located inside the sample flow channel, the sample cell has a task only of sealing against escape of liquid without any further demands on optical properties of the material.

It has now been found, surprisingly, that it is possible to overcome the said problems with sensor platforms when the layer provided for holding the samples covers the outcoupling elements at least in the region of the guided luminescence radiation, and is transparent to this radiation in the region of the bearing surface.

A further subject matter of the invention is a sensor platform composed of a planar optical layer waveguide, comprising a transparent substrate and a waveguiding layer, the waveguide having at least an outcoupling element for coupling out excitation radiation, and on whose waveguiding layer there is located a further tightly sealing layer, which has, at least in a subregion of the excitation radiation, a cutout open at the top, or a cutout which is closed at the top and connected via an inflow channel and outflow channel, for an analytical

sample whose depth corresponds at least to the depth of penetration of the evanescent field of the luminescence light guided in the waveguide, and the layer consists of a material which, at least on the bearing surface at least in the depth of penetration of the evanescent field of the luminescence light guided in the waveguide, is transparent to this luminescence light, and the outcoupling element or the outcoupling elements being completely covered by the material of the layer at least in the outcoupling region of the luminescence radiation.

The depth of the cutouts is preferably at least 1 μm , with particular preference at least 10 μm .

The statements and preferences previously made, including the one-dimensional and two-dimensional arrangements, hold for the waveguide.

The layer forming a cutout is transparent to electromagnetic radiation in the region of the luminescence wavelength, at least on the bearing surface. The material can be an inorganic material such as, for example, glass or quartz, or transparent organic polymers (organic glasses) such as, for example, polyesters, polycarbonates, polyacrylates, polymethacrylates or photopolymers. The layer is preferably formed from an elastomer. Particularly suitable are elastomers of polysiloxanes such as, for [lacuna] polydimethylsiloxanes, which are soft and flexible as well as frequently self-adhesive materials. The materials for the layer are known and are commercially available in part.

The layer with at least one cutout can be produced by means of conventional shaping processes, for example casting and pressing processes, or by means of grinding, punching and milling processes from appropriately preshaped semi-finished products. The layer can also consist of photopolymerizable substances which can be applied directly to the waveguiding layer by means of lithographic methods. Furthermore, the layer can consist of essentially inorganic materials such as Si or SiO_2 in which the sample containers are produced by means of etching methods, these materials being transparent in the region of the contact surface with luminescence light which is to be guided, at least up to the depth of penetration of the evanescent field of guided luminescence light, preferably up to a depth of at least 1 μm , with very particular preference up to a depth of at least 10 μm , at least in the case of the luminescence wavelength.

With very smooth surfaces (surface roughness in the nanometer range or below) the self adhesion can lead through adhesion to tight seals in the case of stiff materials. Elastomers are generally self-adhesive. A possible slight surface roughness is also very desirable, in order to suppress light scattering. In these cases, the layer is preferably produced as a separate body and applied with a tightly sealing contact to the waveguide, on whose surface there can be located immobilized detection elements, possibly on an additional thin (that is to say <100 nm) adhesion promoter layer.

The layer can consist of a single material which is transparent, at least for the luminescence wavelength of the analyte sample, and free from luminescence, or else be present as a two-ply layer whose first [lacuna], which is brought into contact with the waveguide surface, is transparent at the luminescence wavelength of the analyte and is free from luminescence, while the adjoining cover layer is then preferably designed to absorb radiation. In this case, the thickness of the first layer, in contact with the waveguide surface, comprises at least the detector penetration of the evanescent field of guided luminescence light, that is to say approximately one wavelength. This first layer is preferably 0.8 μm to 10 mm, more preferably 0.01 mm to 10 mm thick.

In an advantageous refinement, jumps in refractive index on the waveguiding layer, along the propagation path of the luminescence light, which is to be guided up to the optical outcoupling elements, are minimized in the bearing layer. This can be performed by rounding the boundary of the cutout on the bearing surface in a fashion perpendicular to the waveguiding layer. A rounded transition perpendicular to the surface of the waveguide, at the boundaries of the cutouts, means that a right angle is avoided. The rounding can, for example, be a part of a circular, parabolic or hyperbolic curve. In the case of soft and flexible materials for the layer, the rounding is formed automatically in the course of being pressed onto the waveguide. The rounding can, however, also be preformed by the shaping process. Jumps in refractive index can also be minimized if the cutout is possibly continuously tapered in the direction of the propagation of the luminescence light. Another possibility consists in selecting the material of the layer forming the cutout to have a refractive index close to or equal to the refractive index of the analyte sample.

If a sensor platform contains a multiplicity of sensor elements and sample containers, it can be advantageous to provide light absorbing materials, for example dyes, pigments, carbon black, metal oxides or metals for the purpose of suppressing scattered radiation and/or

The sensor platform according to the invention can be provided in various embodiments, a distinction being made between embodiments with an open cutout (embodiment A), and a closed cutout (embodiment B, flow cells).

The open cutouts can have any desired shape; the contact surfaces with the waveguide can, for example, be square, rectangular, round or ellipsoid. The shape of devices according to the invention can correspond, for example, to the shape of known microtiter plates. The geometrical arrangement of the cutouts is arbitrary per se, two-dimensional arrangements being preferred. Devices and preferences illustrated and described for embodiment B can also be used in essence for embodiment A.

In a sensor platform according to the invention for generating excited luminescence radiation, which has at least one outcoupling element for coupling out luminescence, excited in the near field of the waveguide and coupled into the waveguide, of excited radiation from the waveguide, it is expedient that the layer constructed as a flow cell also covers the or each outcoupling element. In a relevant development, it is provided that the cutout is arranged entirely next to or between each outcoupling element, such that each outcoupling element is free from sample material. This has the advantage that constant coupling

It is expedient, furthermore, for use in routine analytical operation that the layer in contact with the waveguide consists of a flexible material which tightly seals the at least one cutout when applied to the waveguide. As a result, in the case of cutouts closed at the top it is possible without further aids such as seals to conduct sample material without leakage through a flow cell by placing the flow cell onto the waveguide.

a) comprising [sic] an optical layer waveguide with a transparent substrate and a waveguiding layer;

b) an analyte sample which is located in contact with the waveguiding layer;

c) an electric or optical energy source which is arranged such that the electrodes of the electric energy source are located in direct contact with the analyte sample, or the excitation radiation of the optical energy source is directed directly onto the analyte sample at an inclined or right angle, or a reservoir containing a chemical which excites a chemiluminescence in contact with the analyte sample; and

d) an optoelectronic detection unit for measuring the luminescence radiation generated by the action of an electric field or excitation radiation.

The energy source c) is preferably a light source and, as the case may be, focusing lenses, optical filters or both, whose excitation radiation is guided at an inclined or right angle either from above through the analyte sample and the waveguide, or from below through the waveguide and the analyte sample, in each case outside the outcoupling element or elements.

Otherwise, the previously presented preferences and embodiments hold for the device according to the invention. Further details on optical waveguides, optical elements for focusing, filters and guidance of excitation and luminescence light, as well as detection units for the excited radiation are described in WO 95/33197 and WO 95/33198.

The method according to the invention, and the device are suitable in general for determining luminescence light which is generated in the optical near field of a waveguide, for example luminescence radiation generated chemically, electrically or, preferably, optically. Optical excitation is applied particularly in affinity sensor technology, in which the binding of the target molecules on their corresponding detection elements is detected using suitable fluorophores and by immobilizing one of the affinity partners. In this case, the immobilized affinity partners can be arranged both in an isolated fashion and embedded in larger functional structures up to whole cells. Examples of such analyses are human diagnosis, animal diagnosis and plant diagnosis, biochemical analysis, the investigation of reaction mixtures for process control, and environmental analysis. The analyte samples are preferably liquid, and measurements are possible without difficulty even in turbid solutions. The analyte samples can, for example, be egg yolk, blood, serum, plasma, liquids from internal organs (for example the lymph system) or plant extracts, soil extracts, water samples or synthetic liquors of biochemical processes. This method renders possible, for example, the qualitative or quantitative (after calibration) determination of antibodies and antigens, receptors or their ligands, oligonucleotides, DNA strands or RNA strands, DNA analogs or RNA analogs, enzymes, enzyme substrates, enzyme cofactors or inhibitors, lectins or carbohydrates. The method is also suitable for affinity screening in searching for and developing pharmaceutical or agrochemical active substances, for analysis in

combinatorial chemistry, for genotyping/phenotyping and mutation analyses of proteins and DNA strands or RNA strands.

Figure 1 illustrates a sensor platform (1), designed as a microtiter plate, with four sensor fields. Here, 2 are cutouts for holding an analyte sample 3, which are located centrally between four outcoupling gratings 4. The sensor fields are optically separated with the aid of structures 16 composed of light-absorbing material.

Figure 2 illustrates a measuring device according to the invention. Here, 1 represents a sensor platform which is designed as a microtiter plate and whose sensor fields are located between outcoupling gratings 4 for the luminescence radiation 5, 6. The analyte samples 3 are illuminated at right angles through the substrate 7 and the waveguiding layer 8 with excitation light beams 9. The luminescence radiation 5 penetrating in the immediate proximity into the waveguide 8 and propagating in the waveguide, is guided as discrete beams 6 via the outcoupling gratings 4 and a dichroic mirror filter 10 to the imaging optics 11, and from there to a detection device 12 (CCD camera or photomultiplier). The excitation light beams 9 are fed to the analyte sample (3) [sic] via the reflecting surface of the dichroic mirror (10) [sic]. The excitation light beams 9 originate from an excitation light source (laser) 13. The sample containers are designed as cutouts in a cover layer 14 which, outside optically transparent interlayers 15 provided in the immediate proximity of the coupling gratings 4, consists of light-absorbing material in order to avoid optical crosstalk between neighboring cutouts. In addition to an absorbing cover layer 14, it is possible for structures 1 [sic] composed of light-absorbing material (for example chromium) also to be applied directly to the waveguiding layer, directly onto the sensor platform, designed as a microtiter plate 1, between the neighboring analyte cutouts, in order to prevent optical crosstalk from luminescence light 5 propagating in the waveguide 8.

The following example explains the invention in more detail.

Example:

The effectiveness of the excitation method in the volume of an analyte sample 3 is tested with the aid of a DNA hybridizing assay. The waveguide consists of Corning glass C7059 as substrate material 7 and Ta₂O₅ as waveguiding layer 8 (layer thickness 150 nm), and contains two outcoupling gratings 5 with a modulation transfer factor of approximately 10 nm and a grating period of 320 nm. The cutout for the analyte sample is located in the middle of

the grating at a distance of 5 mm. In order to immobilize oligonucleotide detection elements, the waveguiding surface is silanized with 3-glycidoxypropyltrimethoxysilane in the liquid phase (ortho-xylene). The following oligonucleotide is covalently immobilized as detection element on the functionalized silane layer with a typical occupation density of 10%.

Amino-(C6-bridging group)-5'-CACAATTCCACACAAC-3'.

The covalent bonding of the oligonucleotide is performed via the free amino group of the oligonucleotide and the epoxide group of the silane layer. Immobilization is performed with an oligonucleotide concentration of 0.1 mM oligonucleotide in 100 mM of bicarbonate buffer with a pH of 8.7.

Hybridization with an oligonucleotide which is complementary to the detection element and is fed for 3 minutes in continuous flow via a buffer solution is used for detection in a specific binding assay. The oligonucleotide used for detection is likewise marked at the 5'-end with the fluorescence dye Cy5. The sequence of the oligonucleotides used for detection is as follows: Cy5-5'-GTTGTGTGGAATTGTG-3'.

The complementary oligonucleotide is applied in increasing quantities from 0.5 to 500 pM, the sensor surface being regenerated with NaOH (10 mM) before each application.

The excitation surface in the analyte sample for the laser light with a wavelength of 633 nm is 0.5 mm^2 , and the intensity of the excitation light is 2.4 mW. The sample container is illuminated from the substrate side at an angle of approximately 45° to the substrate normals. The direction of illumination likewise forms an angle of approximately 45° (in conjunction with virtually perpendicular outcoupling) to the direction of the fluorescence outcoupling light 6 at a coupling grating 5, and thus keeps the background signal of the measurement at a very low level (and correspondingly low noise) owing to the opposite directions of excitation and emission and to the fact that the excitation and emission sites are separated from one another in space.

In order to determine the optical response signal, the ratio of the net signal (maximum sensor signal minus background signal in the buffer) to the background noise is given as a function of the concentration. The measurement result is represented in the following table:

005080" 484T0960

Table

Concentration (pM):	0.5	1	5	10	25	50	500
Signal:noise:	1.5	3.5	11.7	53.5	58.0	118.8	225.1

The standard deviations of the signal:noise values from three sequentially performed, concentration-dependent measurement series is $\leq 4\%$.

Variable	Mean	SD	Min	Max
Age	38.5	10.5	25	55
Gender	0.5	0.5	0	1
Marital status	0.5	0.5	0	1
Education	12.5	1.5	10	15
Income	15.5	5.5	10	25
Health status	1.5	0.5	1	2
Stress level	2.5	1.5	1	4
Life satisfaction	3.5	1.5	1	5
Work satisfaction	3.5	1.5	1	5
Family satisfaction	3.5	1.5	1	5
Community satisfaction	3.5	1.5	1	5
Overall satisfaction	3.5	1.5	1	5

[illegible]

1. A method for exciting and determining a luminescence in an analyte sample which is located in contact with the waveguiding layer of an optical layer waveguide, wherein the luminescence is generated by non-evanescent excitation in the volume of the analyte sample, and the luminescence radiation generated in the immediate proximity of the surface of the waveguiding layer is conducted to the measuring device and determined after penetrating said waveguiding layer.
2. The method as claimed in claim 1, wherein luminescence radiation is generated electrically, chemically or by optical excitation of radiation.
3. The method as claimed in claim 1, wherein use is made as layer waveguide of a planar waveguide with outcoupling elements for the luminescence light.
4. The method as claimed in claim 1, wherein use is made of a sensor platform which has a one- or two-dimensional arrangement of at least two waveguides with diffractive outcoupling elements.
5. The method as claimed in claim 4, wherein the sensor platform is covered with a second layer which contains cutouts for holding an analyte sample in the region of the guided luminescence light.
6. The method as claimed in claim 3, wherein the layer waveguide contains one or more diffractive elements for coupling out the luminescence radiation, and the analyte sample is arranged upstream of or between a plurality of outcoupling elements.
7. The method as claimed in claim 2, wherein the excitation radiation of the optical excitation of radiation is directed onto the analyte sample from the opposite side of the waveguiding layer by a planar waveguide.
8. A device for measuring luminescence generated in an analyte sample by excitation radiation, comprising
 - a) an optical layer waveguide with a transparent substrate and a waveguiding layer;
 - b) an analyte sample which is located in contact with the waveguiding layer;
 - c) an electric or optical energy source which is arranged such that the electrodes of the electric energy source are located in direct contact with the analyte sample, or the excitation radiation of the optical energy source is directed directly onto the analyte sample at an inclined or right angle, or a reservoir containing a chemical which excites a chemiluminescence in contact with the analyte sample; and
 - d) an optoelectronic detection unit for measuring the luminescence radiation generated by the action of an electric field or excitation radiation.

10. A sensor platform composed of a planar optical layer waveguide, comprising a transparent substrate and a waveguiding layer, the waveguide having at least an outcoupling element for coupling out excitation radiation, and on whose waveguiding layer there is located a further tightly sealing layer, which has, at least in a subregion of the excitation radiation, a cutout open at the top, or a cutout which is closed at the top and connected via an inflow channel and outflow channel, for an analytical sample whose depth corresponds at least to the depth of penetration of the evanescent field of the luminescence light guided in the waveguide, and the layer consists of a material which, at least on the bearing surface at least in the depth of penetration of the evanescent field of the luminescence light guided in the waveguide, is transparent to this luminescence light, and the outcoupling element or the outcoupling elements being completely covered by the material of the layer at least in the outcoupling region of the luminescence radiation.

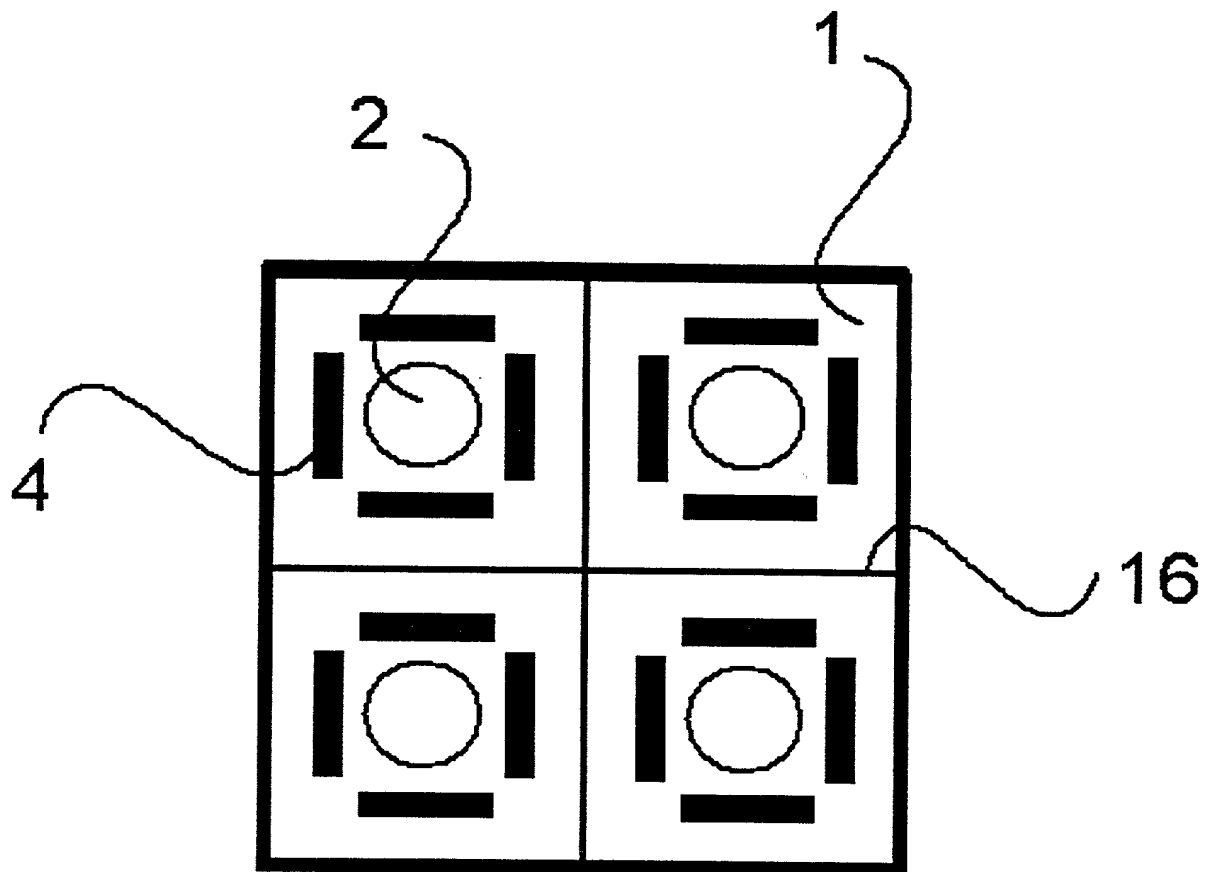
Method for exciting and determining a luminescence in an analyte sample which is located in contact with the waveguiding layer of an optical layer waveguide, wherein the luminescence is generated by non-evanescent excitation in the volume of the analyte sample, and the luminescence radiation generated in the immediate proximity of the surface of the waveguiding layer is conducted to the measuring device and determined after penetrating said waveguiding layer.

Figure 2

[illegible]

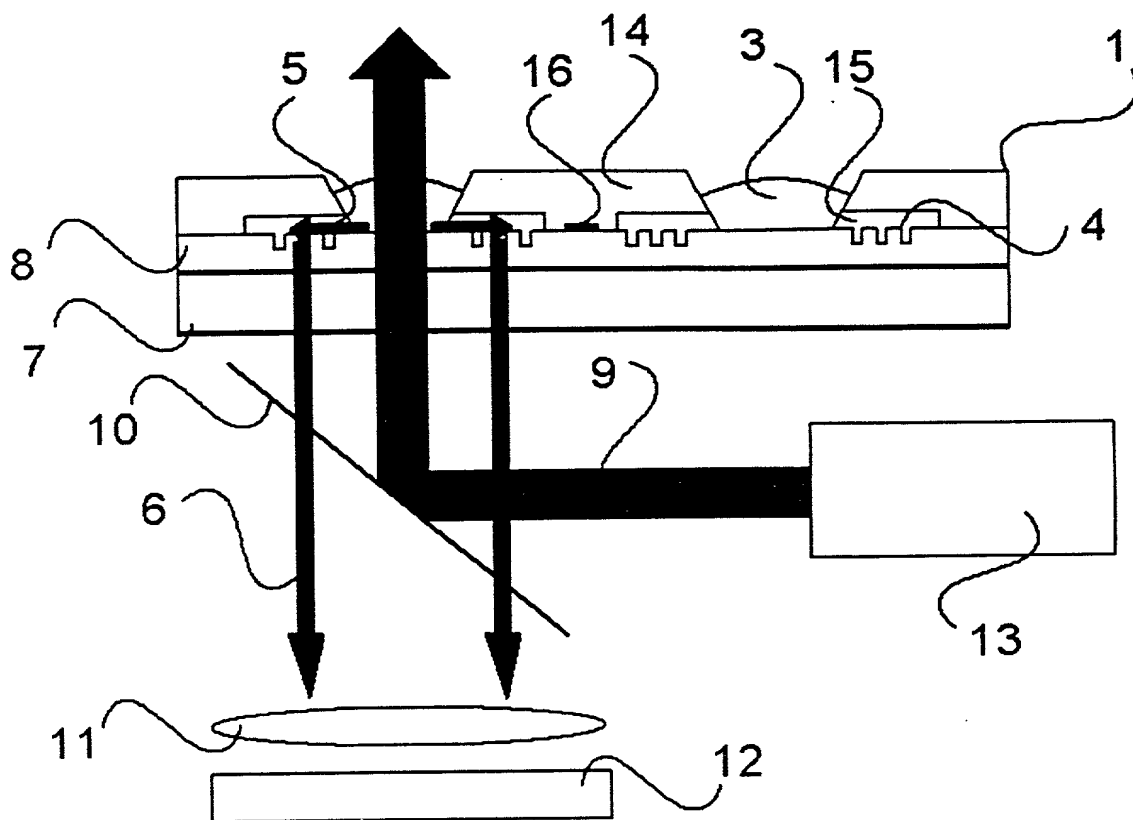
- 1/2 -

FIGURE 1



- 2/2 -

FIGURE 2



DECLARATION AND POWER OF ATTORNEY FOR UNITED STATES PATENT APPLICATION

☒ Original ☐ Supplemental ☐ Substitute

As a below named inventor, I hereby declare that:

My residence, post office address and citizenship are as stated below next to my name, and

I believe I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if more than one name is listed below) of the subject matter which is claimed and for which a United States patent is sought on the invention entitled

METHOD AND DEVICE FOR MEASURING LUMINESCENCE

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COUNTRY/REGION (OR P.C.T.)	APPLICATION No.	FILING DATE (day/month/year)	PRIORITY CLAIMED	
Switzerland	278/98	05/02/98	<input checked="" type="checkbox"/> Yes	<input type="checkbox"/> No
			<input type="checkbox"/> Yes	<input type="checkbox"/> No
			<input type="checkbox"/> Yes	<input type="checkbox"/> No
			<input type="checkbox"/> Yes	<input type="checkbox"/> No
			<input type="checkbox"/> Yes	<input type="checkbox"/> No

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APPLICATION NO.	FILING DATE (day/month/year)
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I hereby claim the benefit under 35 U.S.C. §120 of any United States application(s) listed below and under 35 U.S.C. §365(c) of any Patent Cooperation Treaty international application(s) designating the United States listed below and, insofar as the subject matter of each of the claims of this application is not disclosed in said prior application(s) in the manner required by the first paragraph of 35 U.S.C. §112, I acknowledge my duty to disclose all information known to me to be material to patentability as defined in 37 C.F.R. §1.56 which became available between the filing date(s) of the prior application(s) and the national or Patent Cooperation Treaty international filing date of this application:

United States Application No.	United States Filing Date (day/month/year)	Status (Pending, Abandoned or U.S. Patent No.)	International Application No.	International and Filing Date
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I hereby appoint the following attorneys and agents, each of them with full power of substitution, revocation and appointment of associates, to prosecute this application and to transact all business in the Patent and Trademark Office connected therewith:

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